Attorney Docket No. 061063-0317066 PATENT

Client Reference: OSP-18862

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: OKUBO et al.

Application No.: 10/544,178 Confirmation No.: 8571

Filed: August 1, 2005 Group Art Unit: Unknown

Examiner: Unknown

Title: INSPECTION METHOD, MANUFACTURING METHOD OF PIECE FOR ANALYSIS, ANALYSIS METHOD, ANALYZER, MANUFACTURING METHOD OF SOI WAFER, AND SOI WAFER

April 24, 2006

SECOND PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to the examination of this application on its merits, please enter the following amendments and consider the following remarks: